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| U.S. Department of Commerce, Patent and Trademark Office | Attv Docket No. | Serial No. |
| | 2000-0015-06 | 10/670,406 |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT | | Applicant(s) |
| (Use several sheets if necessary) | | Igor V. Fomenkov et al. |
| | Filing Date | Group |
| | September 24, 2003 | 2828 |

U.S. Patent Documents

| *Examiner Initial | | Document Number | Date | Name | Class | Subclass | Filing Date If Appropriate |
|-------------------|---|-----------------|----------|---------------------|-------|----------|----------------------------|
| Q | A | 4,697,270 | 09/29/87 | Galkowski | 372 | 34 | _____ |
| | B | 4,798,467 | 01/17/89 | Wyeth et al. | 356 | 349 | _____ |
| | C | 4,817,101 | 03/28/89 | Wyeth et al. | 372 | 32 | _____ |
| | D | 4,823,354 | 4/18/89 | Znotins, et al. | 372 | 57 | _____ |
| | E | 4,881,231 | 11/14/89 | Jain | 372 | 32 | _____ |
| | F | 4,883,352 | 11/28/89 | Bruning | 353 | 122 | _____ |
| | G | 4,940,331 | 07/10/90 | Wyeth et al. | 356 | 349 | _____ |
| | H | 5,025,445 | 06/18/91 | Anderson et al. | 372 | 20 | _____ |
| | I | 5,095,492 | 03/10/92 | Sandstrom | 372 | 102 | _____ |
| | J | 5,128,601 | 07/07/92 | Orbach et al. | 372 | 30 | _____ |
| | K | 5,371,587 | 12/06/94 | de Groot et al. | 356 | 349 | _____ |
| | L | 5,373,515 | 12/13/94 | Wakabayashi, et al. | 372 | 20 | _____ |
| | M | 5,420,877 | 05/30/95 | Sandstrom | 372 | 34 | _____ |
| | N | 5,440,578 | 8/8/95 | Sandstrom | 372 | 59 | _____ |
| | O | 5,450,207 | 09/12/95 | Fomenkov | 356 | 416 | _____ |
| | P | 5,524,144 | 06/04/96 | Suzuki | 359 | 176 | _____ |
| | Q | 5,691,989 | 11/25/97 | Rakuljic | 372 | 20 | _____ |
| | R | 5,706,301 | 01/06/98 | Lagerström | 372 | 32 | _____ |
| | S | 5,754,571 | 05/19/98 | Endoh et al. | 372 | 20 | _____ |
| | T | 5,852,621 | 12/22/98 | Sandstrom | 372 | 25 | _____ |
| | U | 5,870,420 | 02/09/99 | Webb | 372 | 58 | _____ |
| | V | 5,978,405 | 11/02/99 | Juhász et al. | 372 | 57 | _____ |

Foreign Patent Documents

| | | | | | | | Translation | |
|--|--|----------|------|---------|-------|----------|-------------|----|
| | | Document | Date | Country | Class | Subclass | Yes | No |
| | | | | | | | | |

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

| | |
|----------------------------|-------------------------------|
| Examiner <i>Jane Vannu</i> | Date Considered <i>8-5-05</i> |
|----------------------------|-------------------------------|

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to

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| U.S. Patent Documents | | | | | | | | |
| | | | Date | Name | Class | Subclass | Filing Date If Appropriate | |
| W | 5,991,324 | 11/23/99 | Knowles et al. | 372 | 57 | | | |
| X | 6,005,879 | 12/21/99 | Sandstrom et al. | 372 | 25 | | | |
| Y | 6,128,323 | 10/03/00 | Myers et al. | 372 | 38 | | | |
| Z | 6,263,002 | 7/17/01 | Hsu, et al. | 372 | 6 | | | |
| AA | 6,348,357 | 2/19/02 | Sano | 438 | 16 | | | |
| | | | | | | | | |
| | | | | | | | | |
| | | | | | | | | |
| | | | | | | | | |
| Foreign Patent Documents | | | | | | | | |
| | | | Date | Country | Class | Subclass | Translation | |
| | | | | | | | Yes | No |
| | | | | | | | | |
| OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | | |
| BB | Ishihara, T., et al., "Advanced Krypton Fluoride Excimer Laser for Microlithography," SPIE Vol. 1674, Optical/Laser Microlithography V (1992) pp. 473-485 | | | | | | | |
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| Examiner <u>James V. Hume</u> Date Considered <u>8-5-05</u> | | | | | | | | |
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